

LGAD Sensors at FBK (selected topics)

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08.10.2022
Rare Pion Decay Workshop

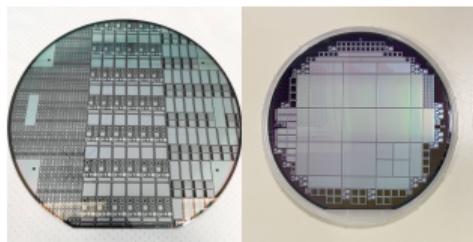


¹mcentisvignali@fbk.eu



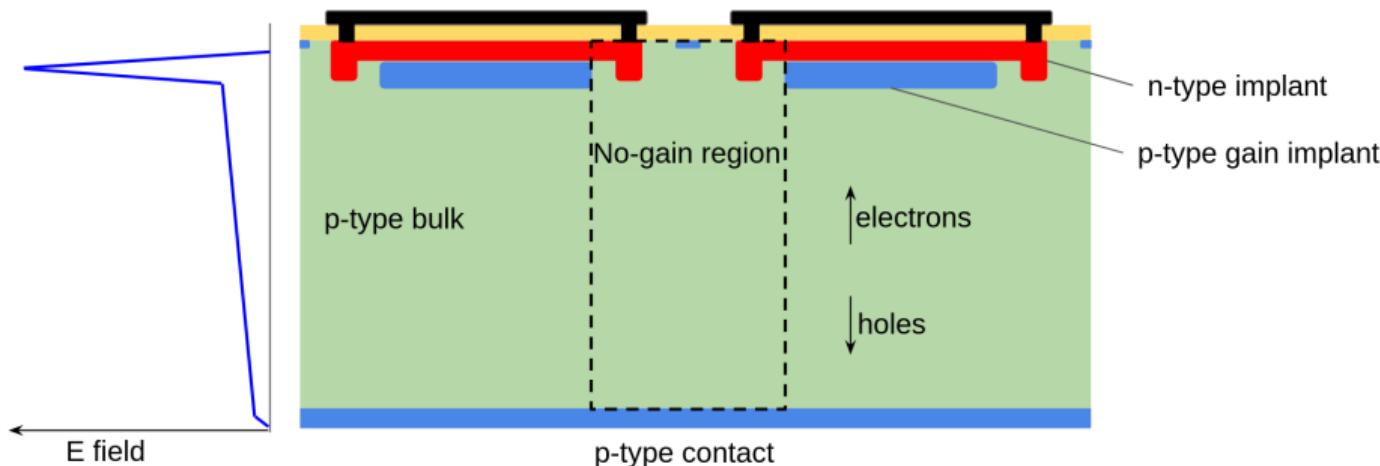
6 inch (150 mm)
Custom CMOS-like process

- LGAD technologies:
- Standard
 - Double sided
 - AC coupled (RSD)
 - Trench isolated
 - DC-RSD



Start	Batch
2015	UFSD1
2017	UFSD2
2018	UFSD3
	RSD1
2019	HD0
	UFSD3.2
	MOVEIT
2020	TI-LGAD RD50
	PSI iLGAD
	HADES
	RSD2
2021	UFSD4
	Space LGADs
	ExFlu
2022	DC-RSD (planned)
	TI-LGAD AIDA (planned)

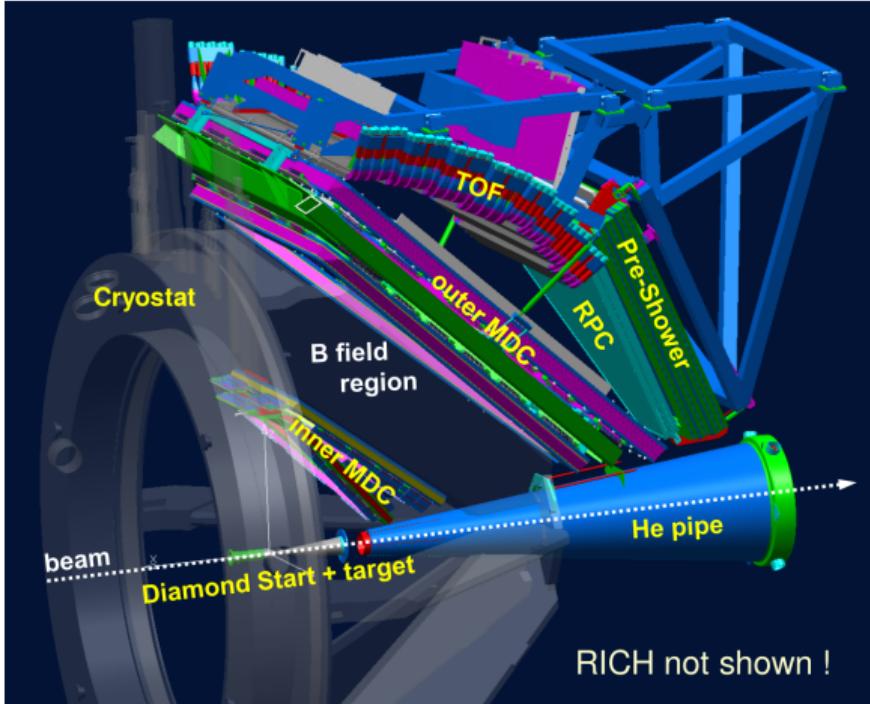
(Standard) Low Gain Avalanche Diodes



- Silicon detectors with charge multiplication
- Gain ≈ 10
- Gain layer provides high-field region
- No-gain region $\sim 30 - 80 \mu\text{m}$
- Time resolution $\sim 30 \text{ ps} \leftrightarrow$ thin $\sim 50 \mu\text{m}$ sensor
- **Improve SNR of the system**
(When the sensor shot noise is not dominating)
- Noise and power consumption
 \Rightarrow low gain

HADES Experiment

[R. Holzmann 54. Winter Meeting on Nuclear Physics] 

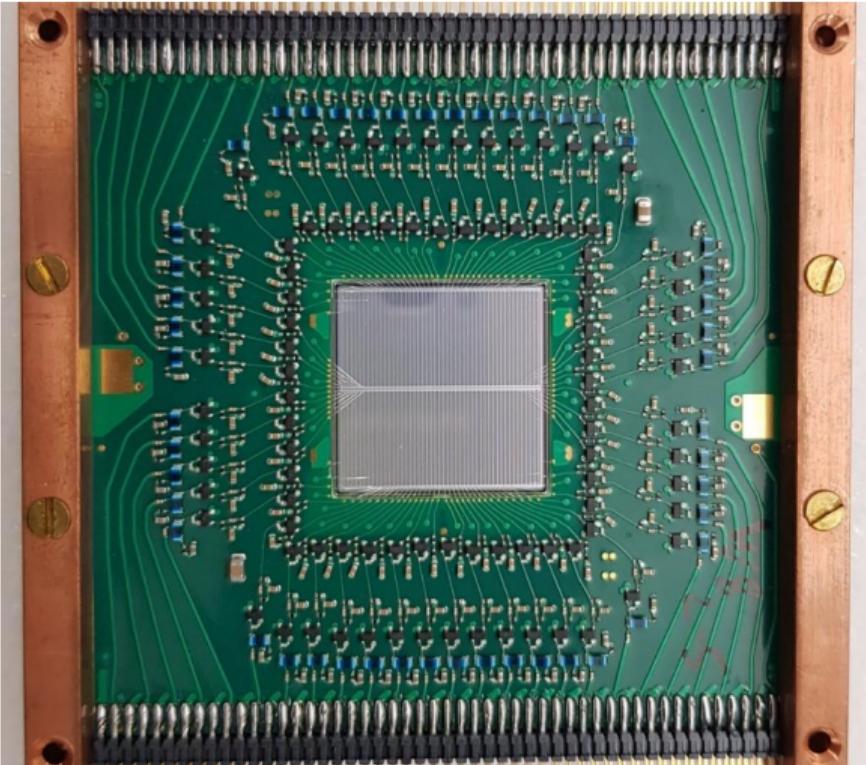


- Fixed target experiment at GSI
- TOF used for particle identification (among other methods)
- T_0 detector
 - Based on diamond detectors
 - Beam monitoring
 - TOF start
 - **Replace diamond with LGADs**

[J. Pietraszko et al. Eur. Phys. J. A 56 (2020) 183] 

LGADs for HADES

[W. Krueger VCI 2022] 



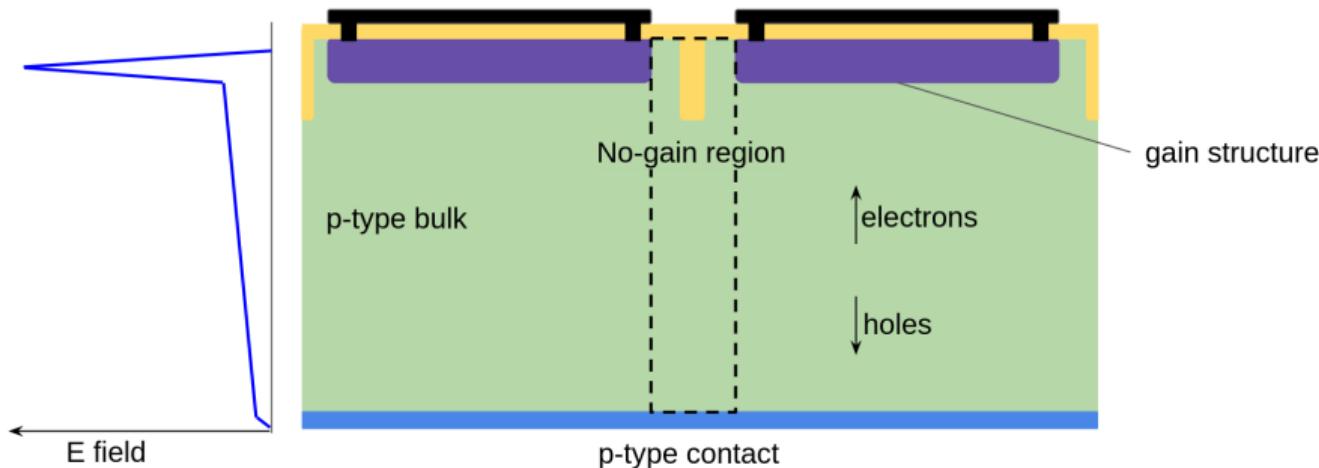
- Strip geometries
- Sensor dimension up to $\sim 2 \times 2 \text{ cm}^2$
- Strip up to $0.387 \times 9.28 \text{ mm}^2$
- Wafers thinned down to $200 \mu\text{m}$ total
- Dicing after thinning

MIP time resolution (largest strips):

[W. Krueger et al. NIMA 1039 (2022) 167046] 

- $\sim 85 \text{ ps}$ in full system tests
- $\sim 130 \text{ ps}$ in the experiment
(discrepancy under investigation)

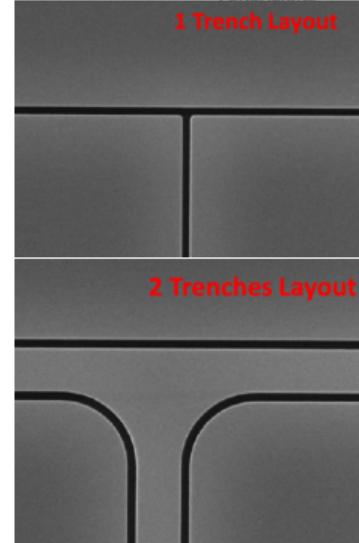
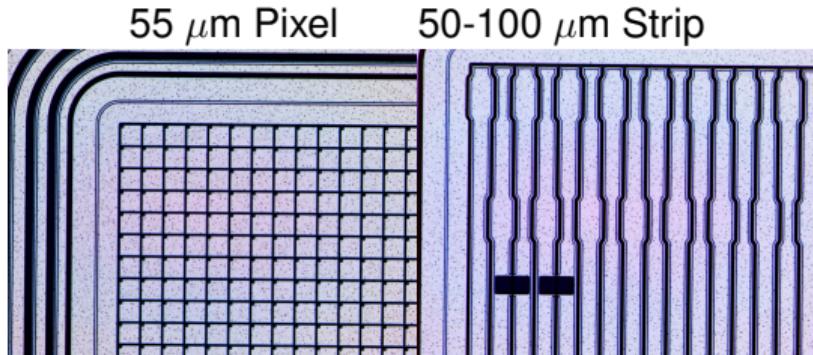
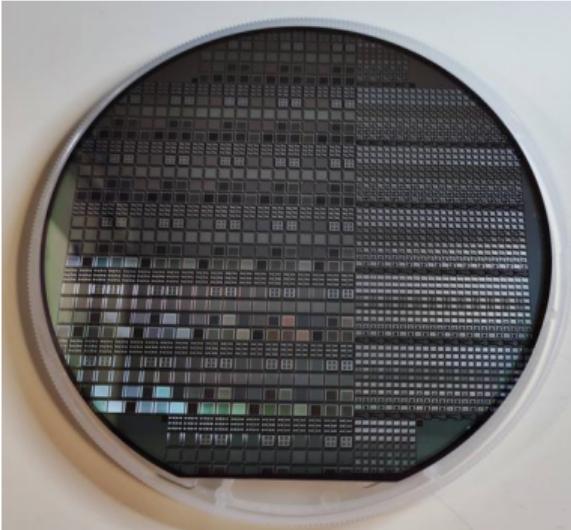
Trench Isolated LGADs



- Trenches substitute the isolation structures
- Trench width about $1 \mu\text{m}$ \Rightarrow fill factor close to 100%

[G. Paternoster et al. IEEE EDL Vol 41 Issue 6 (2020) 884-887] 

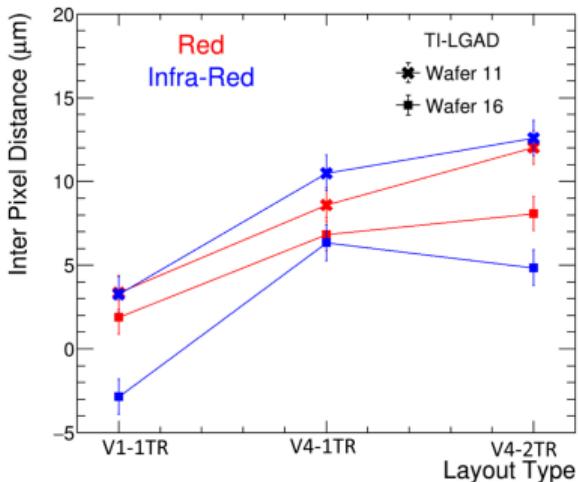
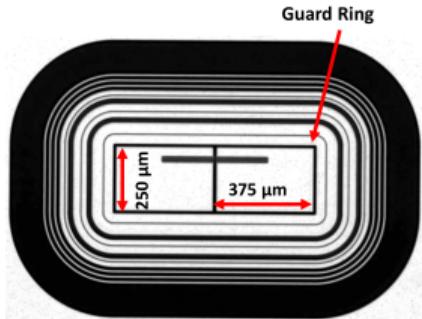
TI-LGADs RD50



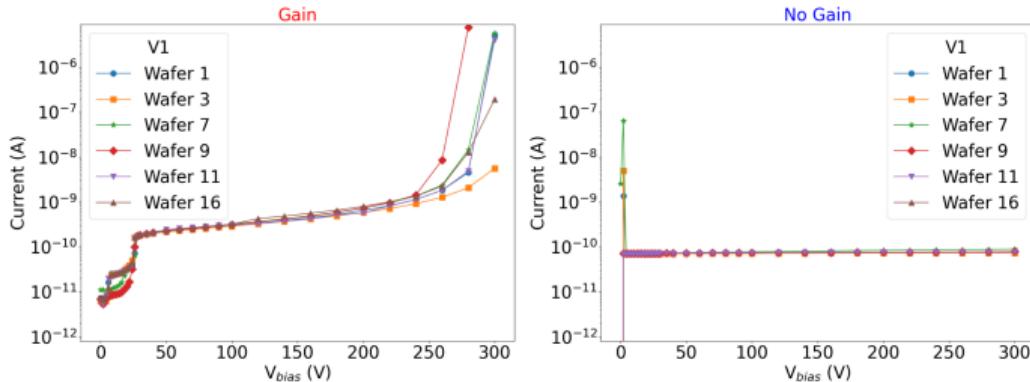
- Second TI-LGAD run
- Project within the RD50 collaboration
- Several pixel and strip geometries
- Different gain structure layouts
- Variations in trench depth and fabrication process

TI-LGAD RD50 Characterization

[A. Bisht Picosecond Workshop 2021] 

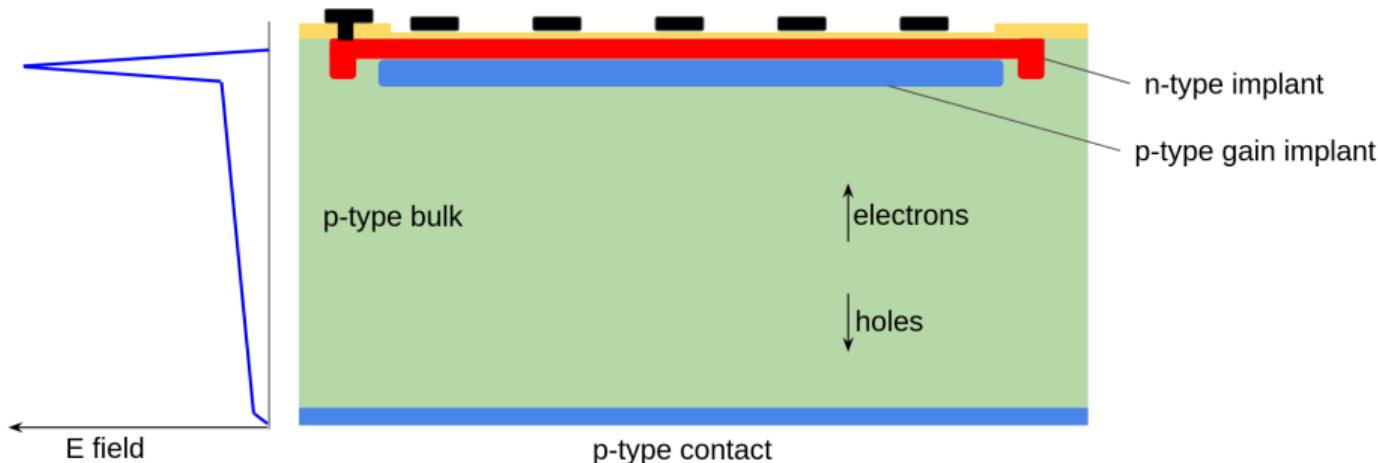


M. Centis Vignali



- Stable trench structures
- Breakdown due to gain layer
- Interpad 3-10 μm with laser [A. Bisht Picosecond Workshop 2021] 
- $\sim 10\times$ improvement from STD LGAD
- Same radiation hardness and time resolution as standard LGADs [M. Senger et al. NIMA 1039 (2022) 167030] 
- (this batch was without carbon coimplantation)

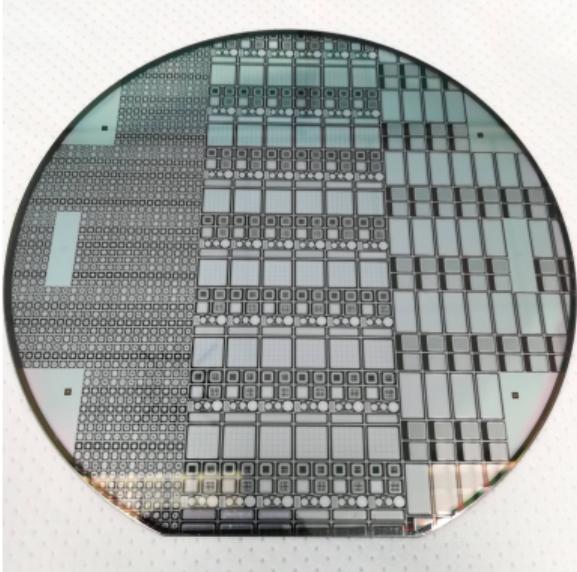
AC Coupled LGADs (RSD)



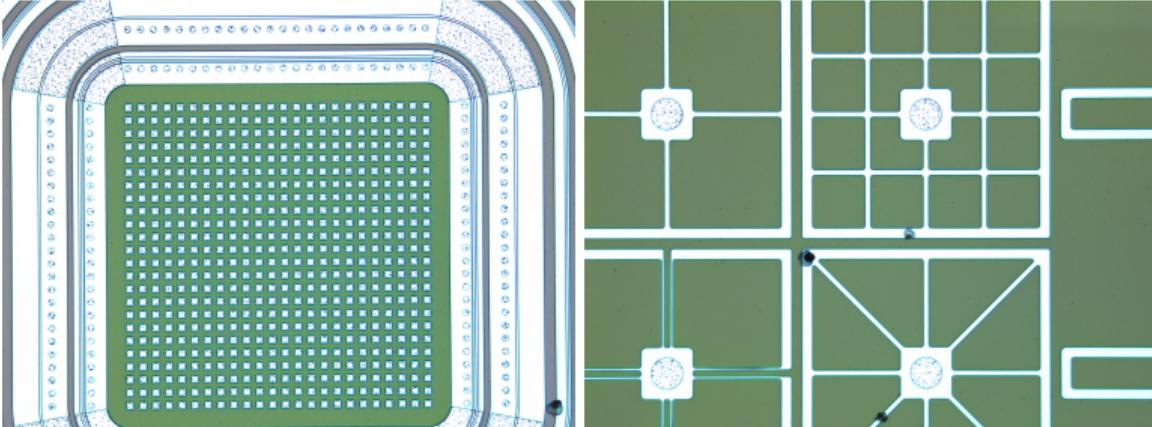
- Continuous gain area in the active region \Rightarrow 100% fill factor
- Readout channels capacitively coupled and resistive layer to limit signal spreading
- No restrictions on channel dimension

[M. Mandurrino et al. IEEE EDL Vol 40 Issue 11 (2019) 1780-1783]

RSD1

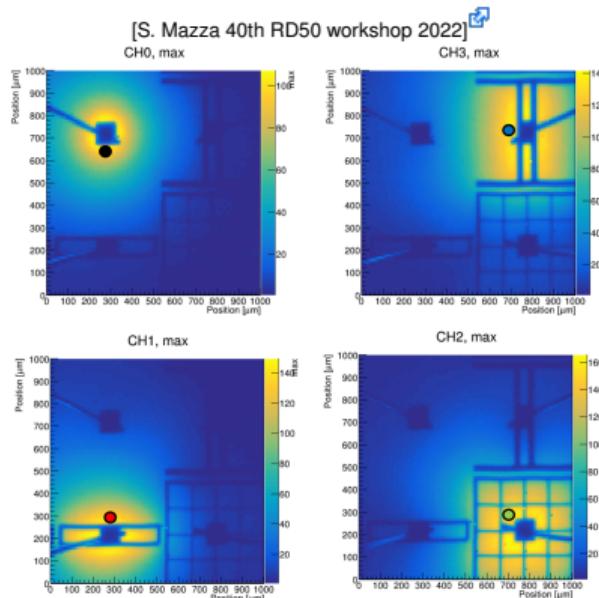
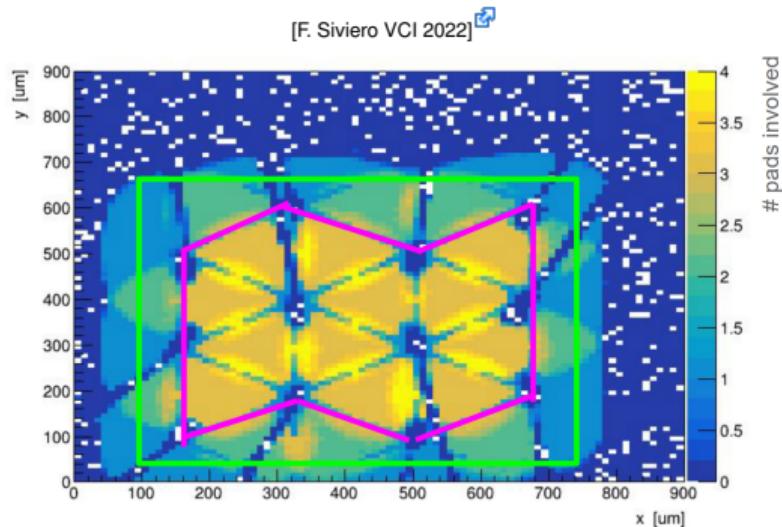


RSD2



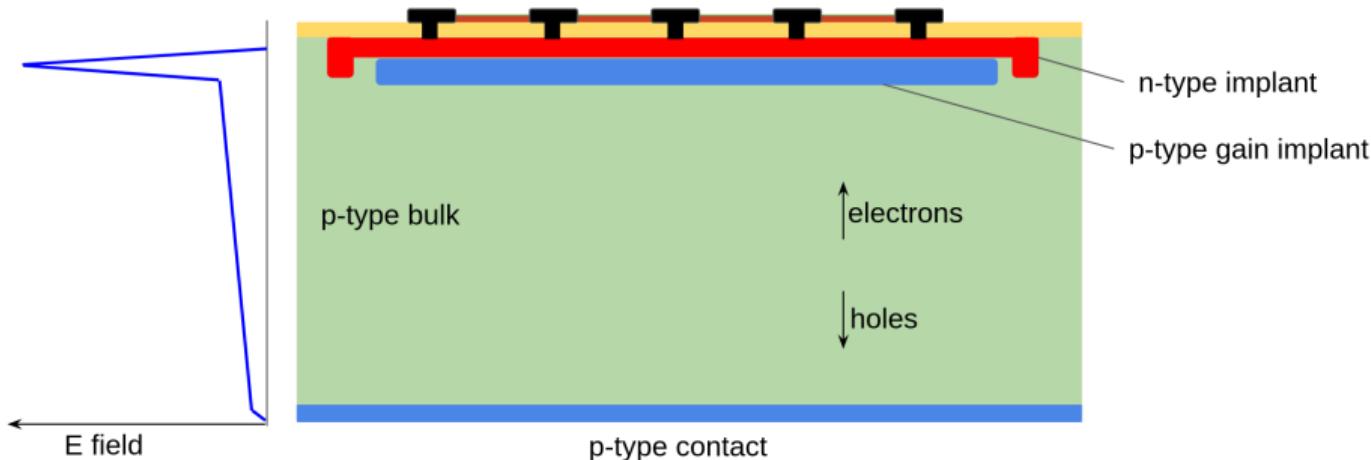
- Several pixel and strip geometries
- Electrode geometries to exploit signal propagation
- Variations of resistive layer
- Variations of coupling dielectrics

RSD Characterization



- $\sim 6 \mu\text{m}$ resolution with $200 \mu\text{m}$ pitch (laser) [F. Siviero et al. NIMA 1041 (2022) 167313] [S. Mazza 40th RD50 workshop 2022] - Time resolution $\sim 44 \text{ ps}$ with $200 \mu\text{m}$ pitch (MIPs) [M. Tornago et al. 2020 IEEE NSS/MIC (2020) 1]

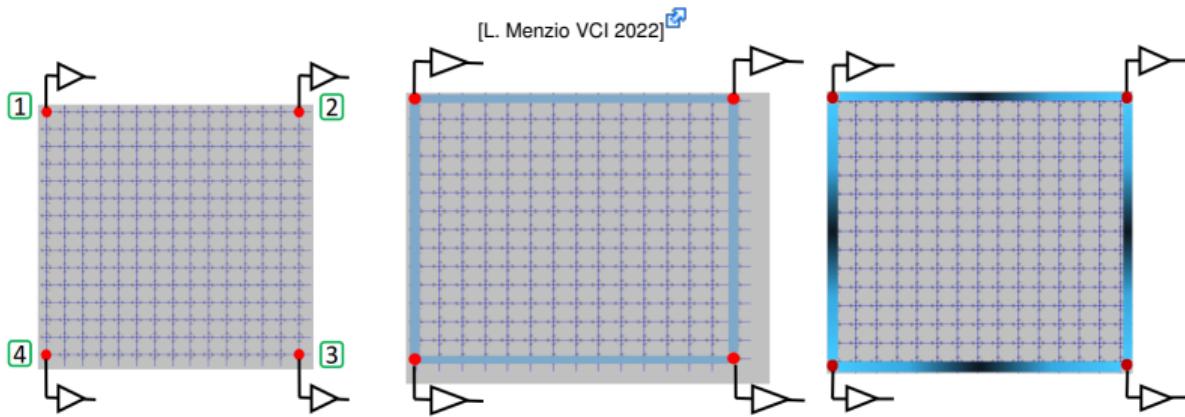
DC-Coupled Resistive Silicon Detectors (DC-RSD)



- Continuous gain area in the active region \Rightarrow 100% fill factor
- Resistive charge division
- Resistors between readout pads to improve reconstruction

[N. Cartiglia 39th RD50 Workshop 2021]

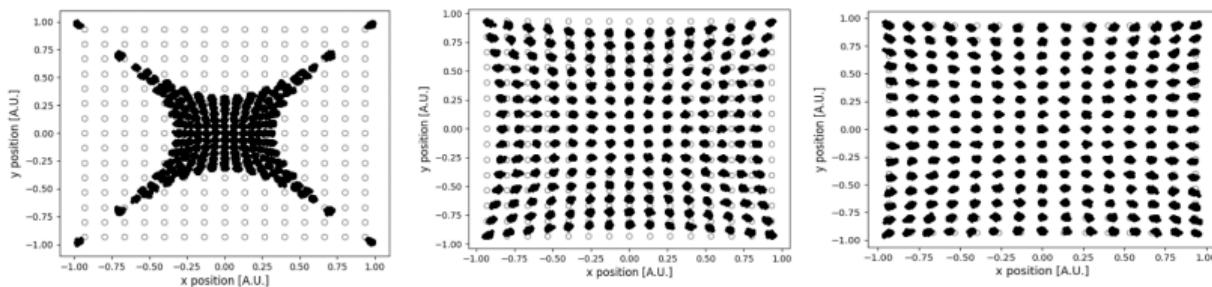
DC-RSD Reconstruction Improvement



Empty circles → input
 Full circles → reco

More details: L. Menzio et al. NIMA 1041

(2022) 167374 



First batch planned for end of the year

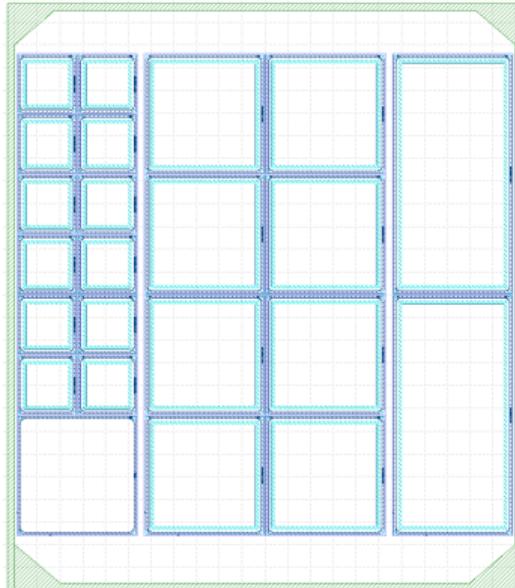
Plans for RSD (AC/DC) and TI-LGADs

2022

- DC-RSD
 - first demonstrator for the technology
 - fabrication tests and design ongoing
- TI-LGADs AIDA
 - evolution from RD50 batch
 - larger devices, up to $\sim 1 \times 1 \text{ cm}^2$
 - carbon coimplantation
 - design ongoing

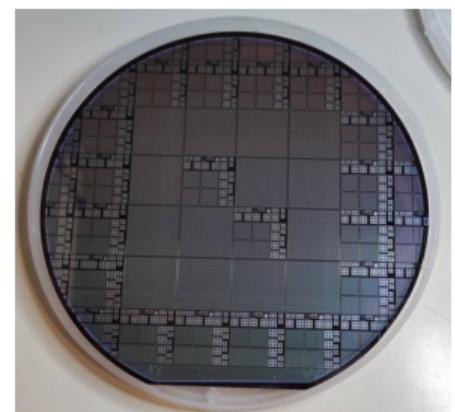
2023

- TI-LGADs GSI,HEPHY,TU-Wien
 - HADES and medical applications
 - strip geometries, sensors up to $\sim 2 \times 2 \text{ cm}^2$
 - wafer thinning

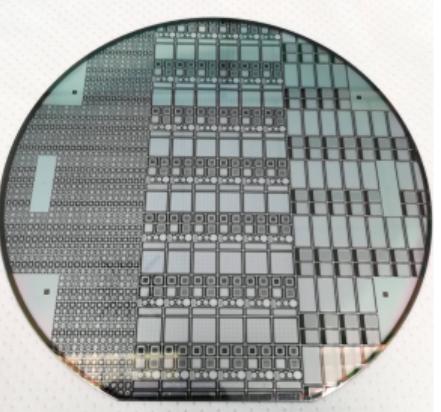




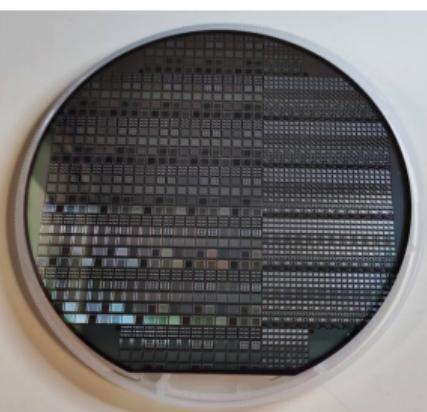
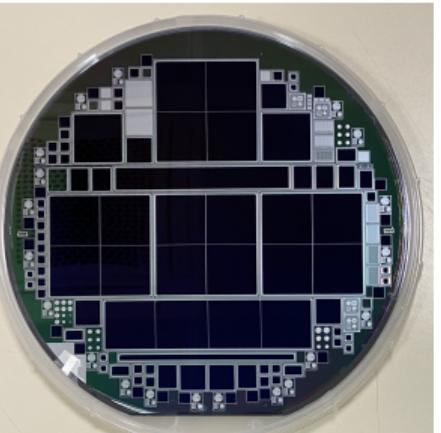
Thank you for your attention



M. Centis Vignali



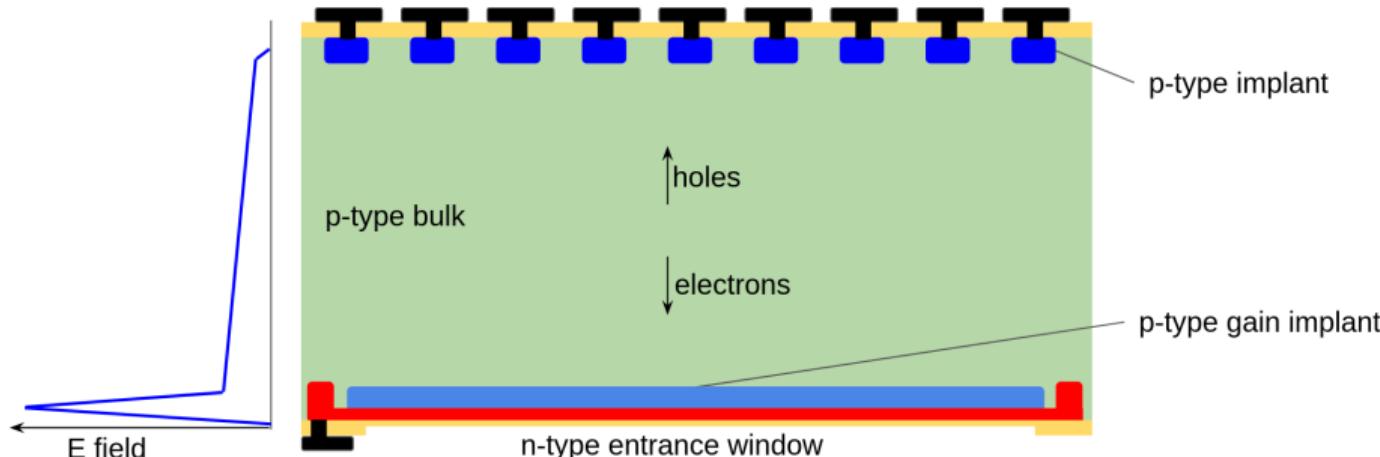
LGAD sensors at FBK



08.10.2022

Backup Material

Double Sided (Inverted) LGADs

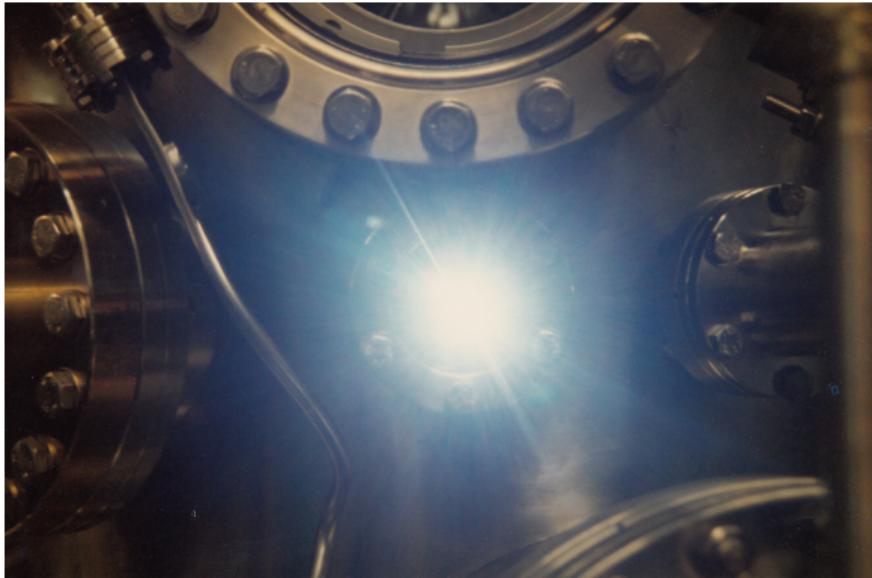


- Continuous gain area in the active region \Rightarrow 100% fill factor
- Double sided process \rightarrow active thickness is the wafer thickness \Rightarrow not optimal for timing
- Readout side is ohmic
- Readout side separated from LGAD side \Rightarrow no restrictions on channel dimensions

[G.F. Dalla Betta et al. NIM A 796 (2015) 154]

X-ray Detection

[Wikipedia CC BY-SA 2.0]



Advantages of LGADs demonstrated in:
[Andrae et al. J.Synchrotron Rad. 26 (2019)
1226-1237] [1]



Detection of soft X-rays: 250 eV - 2 keV

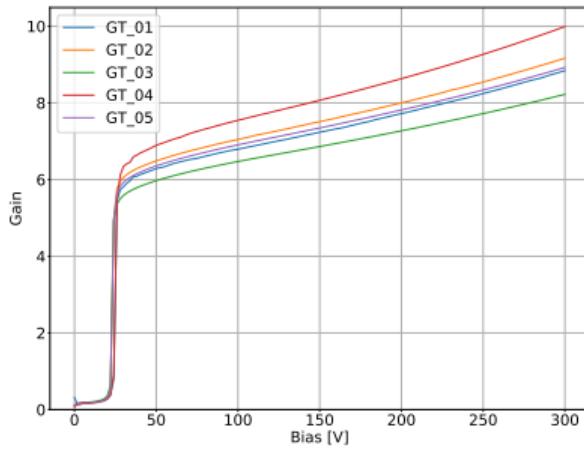
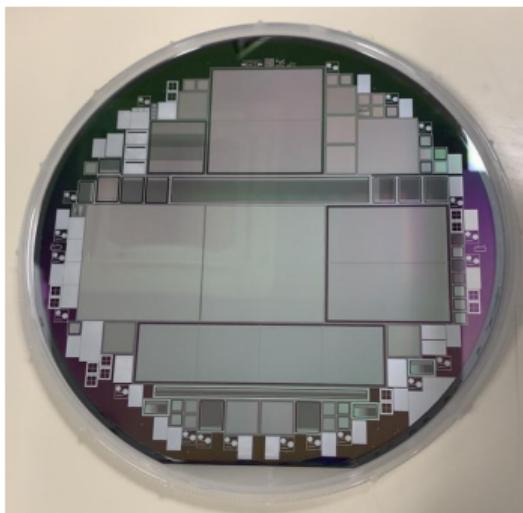
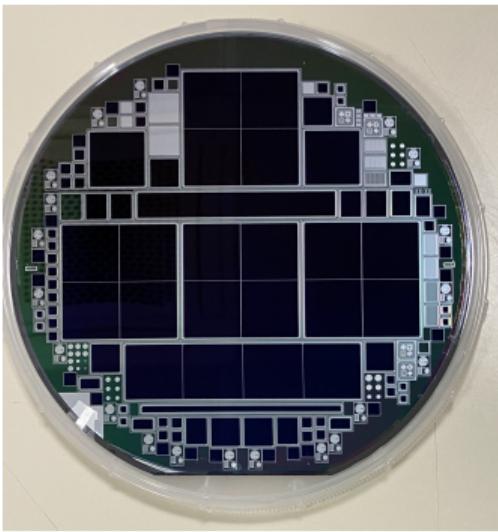
- K-edges of bio elements
→ pharmaceuticals, cell imaging
- L-edges of 3d-transition metals
→ magnets, superconductors, quantum materials ...

Use LGADs:

- Gain to lower the detection limit of photon counting detectors
- Gain to improve SNR of integrating detectors
- Thin entrance window and gain structure must be developed

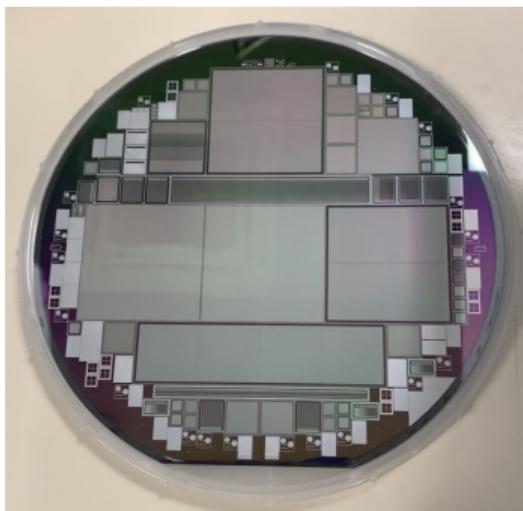
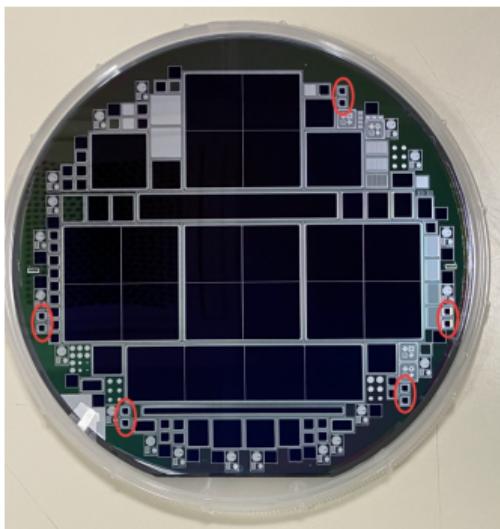
Double Sided LGADs for PSI

Gain with LED (STD gain structure)

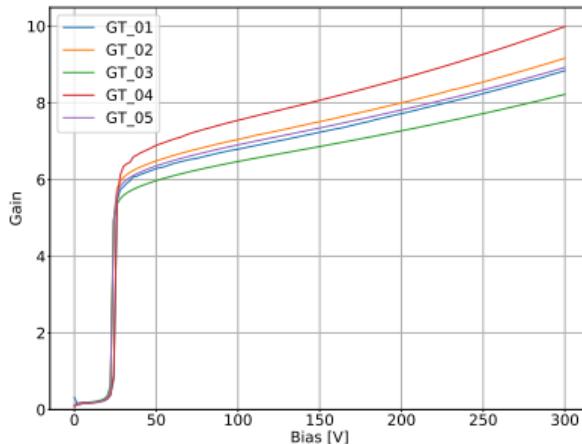


- Several pixel and strip geometries
- Thin entrance window
- Several gain structure designs → make as thin as possible
- Thickness 275 μm
- First results with x-rays at TREDI next week

Double Sided LGADs for PSI

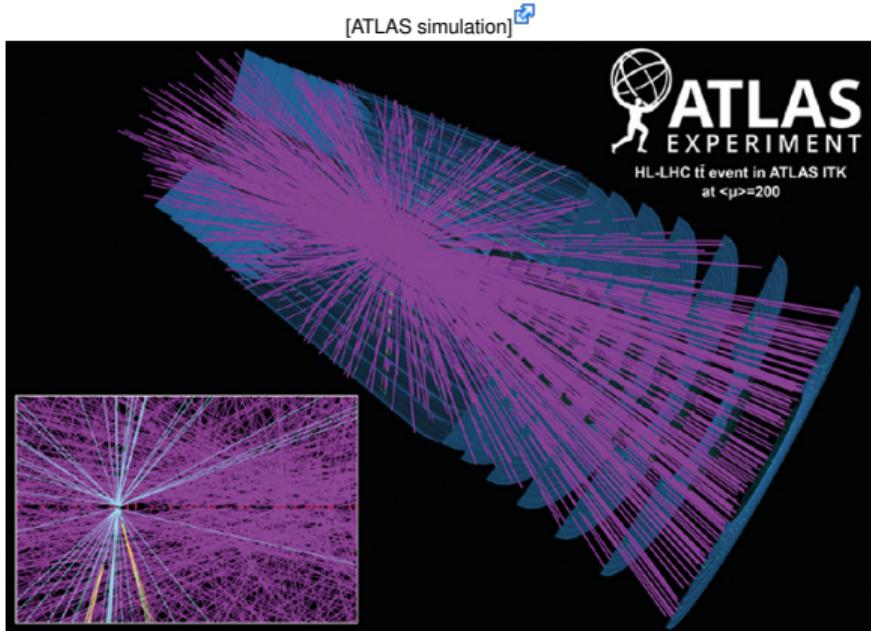


Gain with LED (STD gain structure)



- Several pixel and strip geometries
- Thin entrance window
- Several gain structure designs → make as thin as possible
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High Luminosity LHC



Application described in:

Daniel Spitzbart talk on Wednesday 

Frank Filthaut talk on Wednesday 

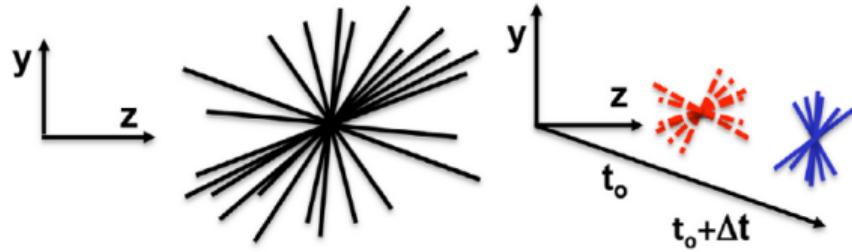
Development within the UFSD project



Use time coordinate to mitigate pile-up

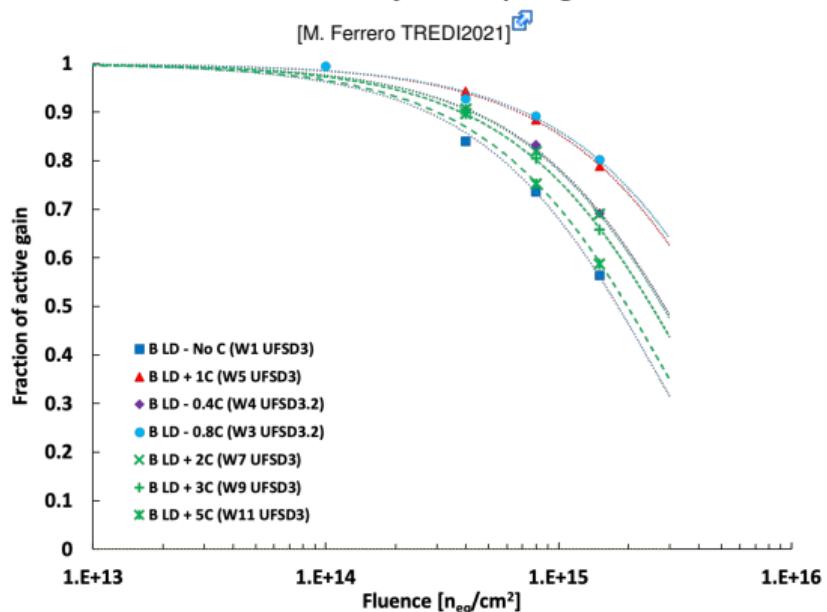
- Track time resolution ≈ 30 ps
- Radiation resistance to few 10^{15} n_{eq}/cm²
- Hit time resolution at end of life ≈ 50 ps

[H. Sadrozinski et al. Rept. Prog. Phys. 81 (2018) 026101] 



Radiation Hardening of LGADs

Gain layer doping



$$N_B(\phi_{eq}) = N_B(0) \exp \{-c\phi_{eq}\}$$

$$c = c(N_B(0))$$

[M. Moll PoS Vertex2019 (2020) 027] 

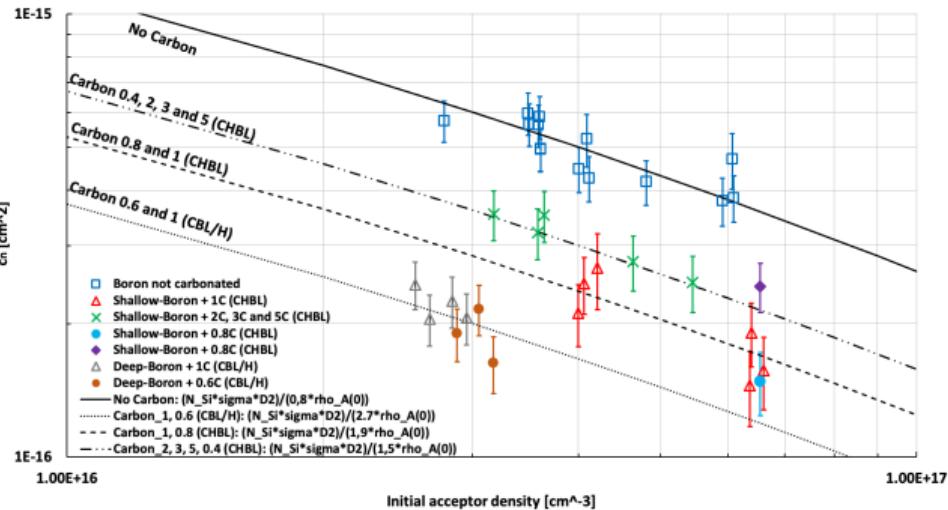
- Acceptor removal:
 $Si_i + B_s \rightarrow B_i$
 $B_i + O_i \rightarrow B_i O_i$ (donor level)
- Carbon \Rightarrow Competing reaction:
 $Si_i + C_s \rightarrow C_i$
 $C_i + O_i \rightarrow C_i O_i$ (neutral)
- Initial B concentration
 \rightarrow higher concentration favored
 \rightarrow narrower B distribution
- Carbon coimplantation
 \rightarrow optimized dose found

Radiation Hardening of LGADs

Removal constant

[M. Ferrero TREDI2021] 

Acceptor Removal parametrization - neutrons



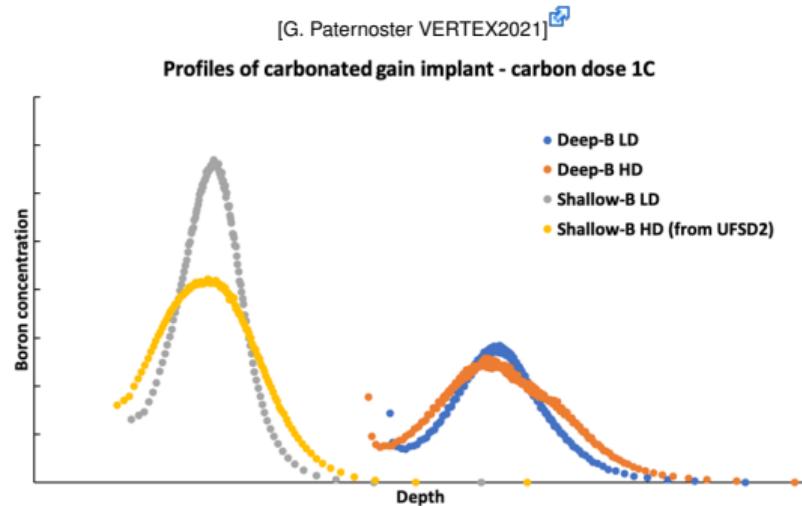
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Radiation Hardening of LGADs



Gain layer position:

- “shallow” → higher B concentration
- “deep” → easier compensation of B loss by increasing bias

[M. Moll PoS Vertex2019 (2020) 027] 

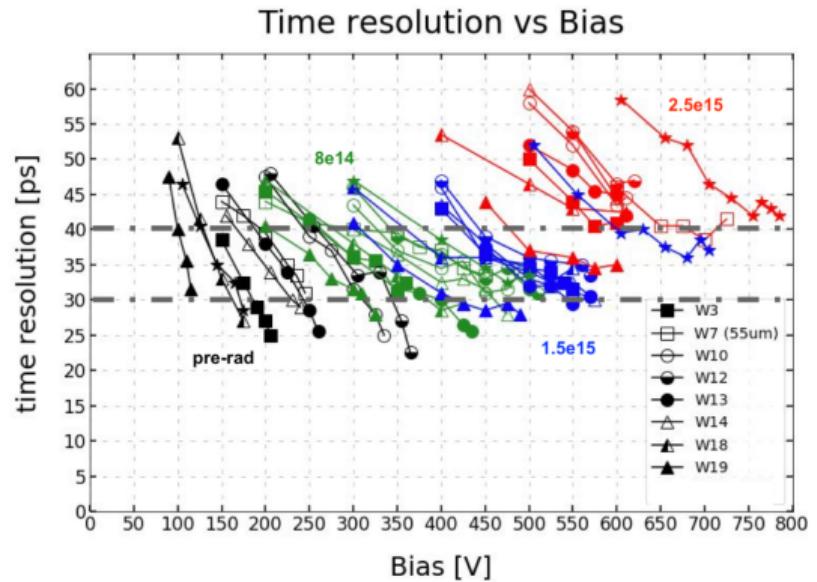
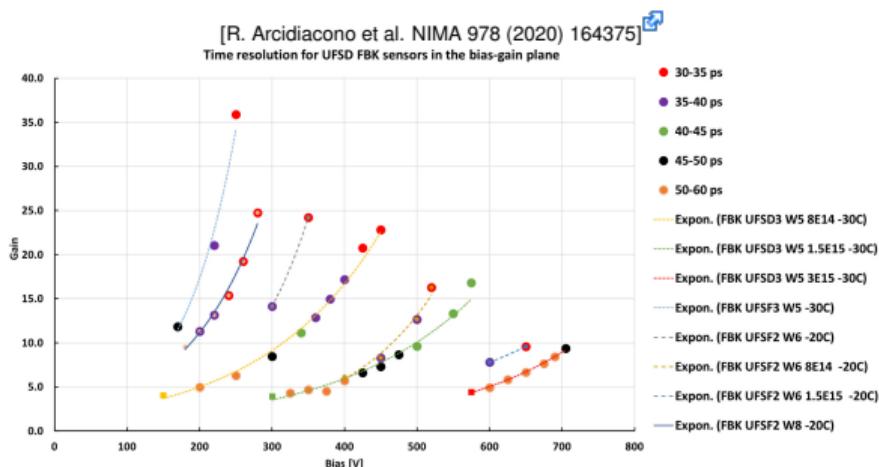
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Radiation Hardness Results

[M. Ferrero Vertex2021]

[R. Arcidiacono et al. NIMA 978 (2020) 164375]

Time resolution for UFSD FBK sensors in the bias-gain plane



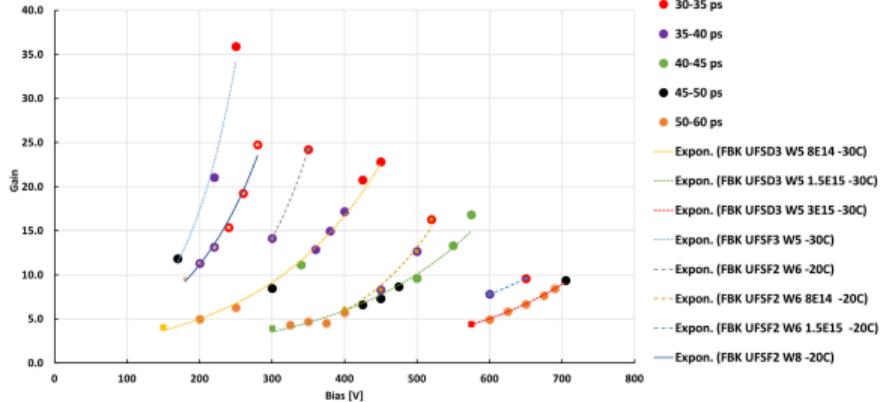
- Time resolution < 40 ps for $2.5 \cdot 10^{15}$ n_{eq}cm⁻²
- Time resolution < 50 ps for $3 \cdot 10^{15}$ n_{eq}cm⁻²

Demonstrated radiation resistance and time resolution for HL-LHC

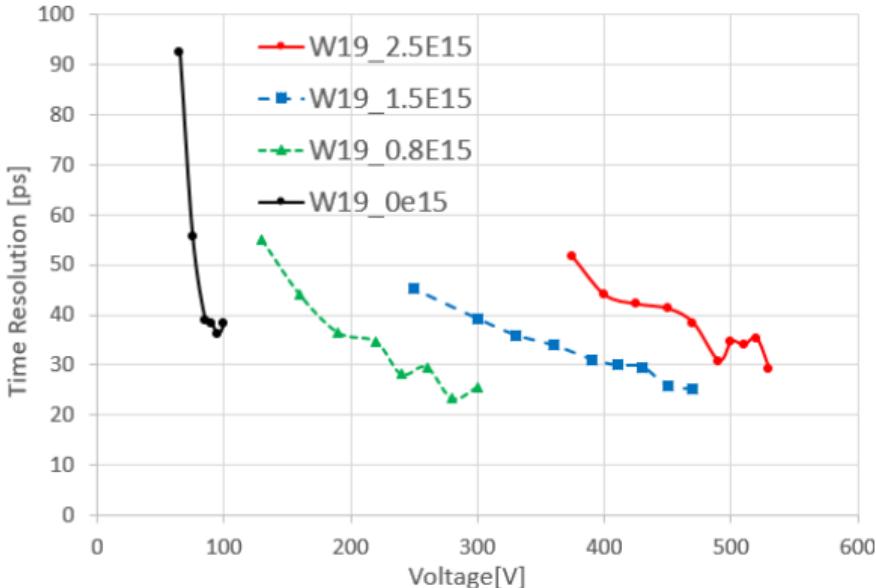
Radiation Hardness Results

[R. Arcidiacono et al. NIMA 978 (2020) 164375]

Time resolution for UFSD FBK sensors in the bias-gain plane



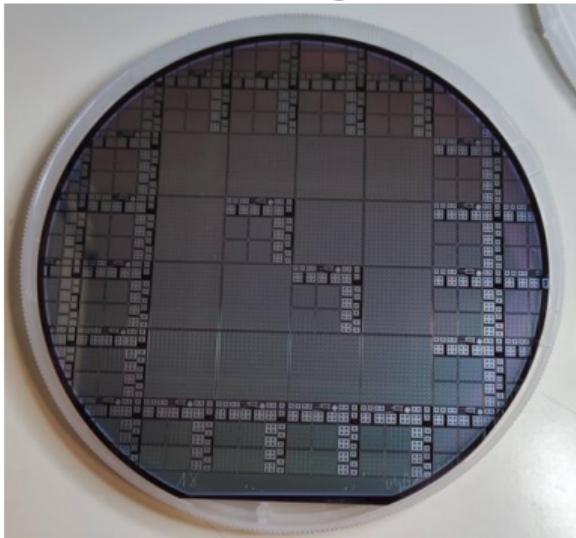
[A. Howard 37th RD50 Workshop]



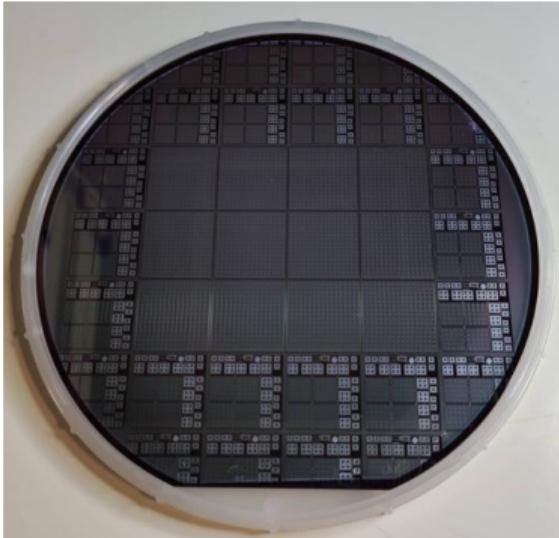
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ATLAS



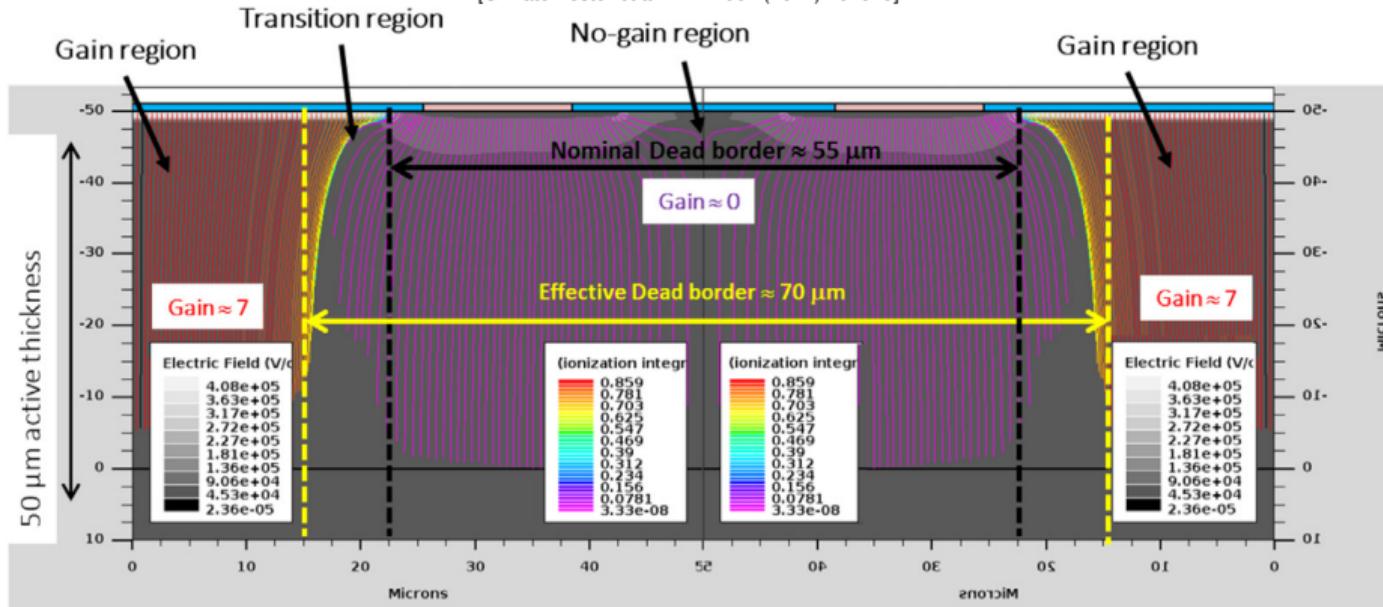
CMS



- Both “shallow” and “deep” gain layers
- Different pad layouts
- Sensors up to $\sim 2 \times 2 \text{ cm}^2$

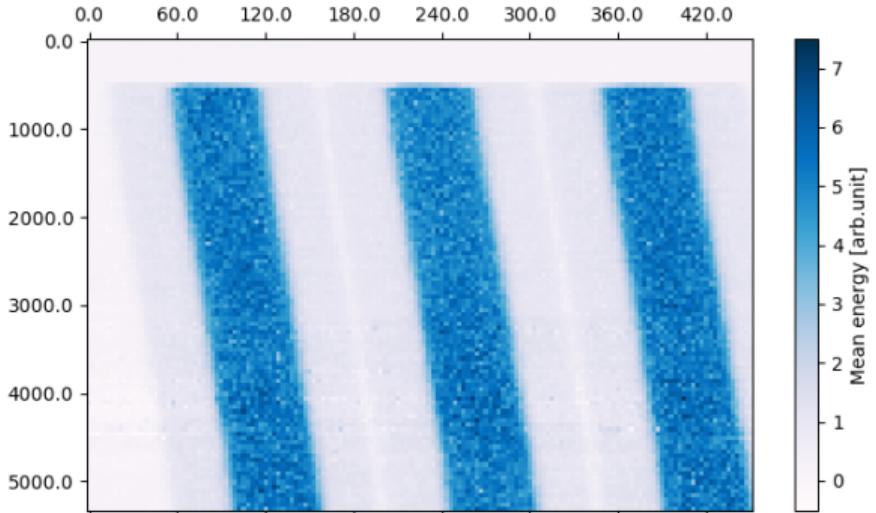
Wafers and sensors for qualification for ATLAS and CMS timing detectors

[G. Paternoster et al. NIMA 987 (2021) 164840] 



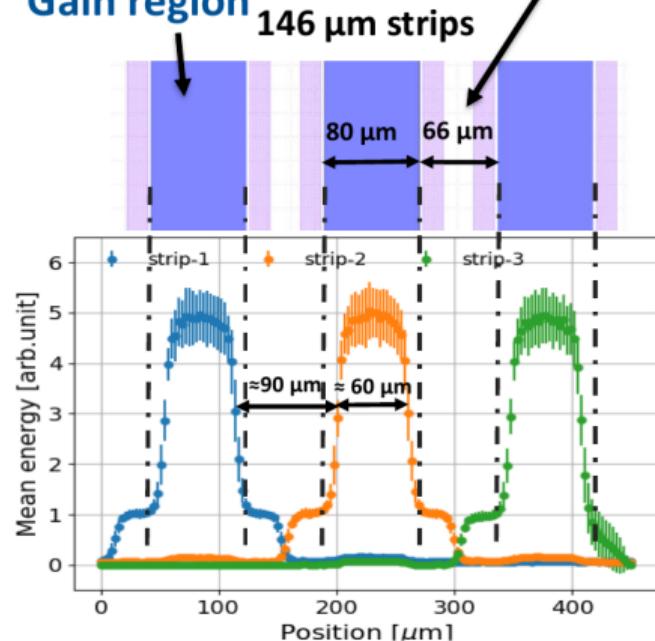
Segmentation: Fill Factor

Focused 20 keV x-ray beam



- Measured FF: $\approx 40\%$
- Impact on detection efficiency

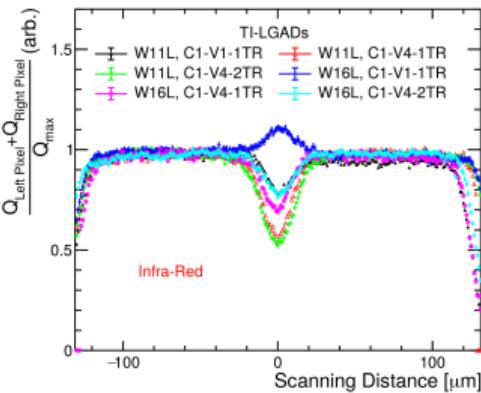
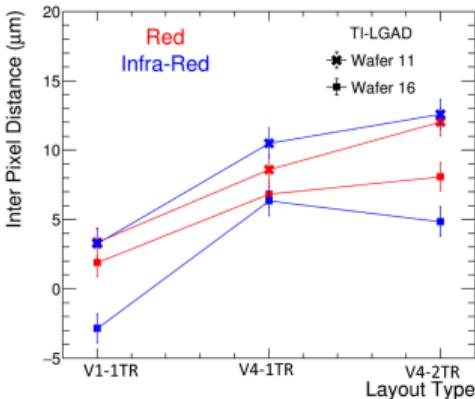
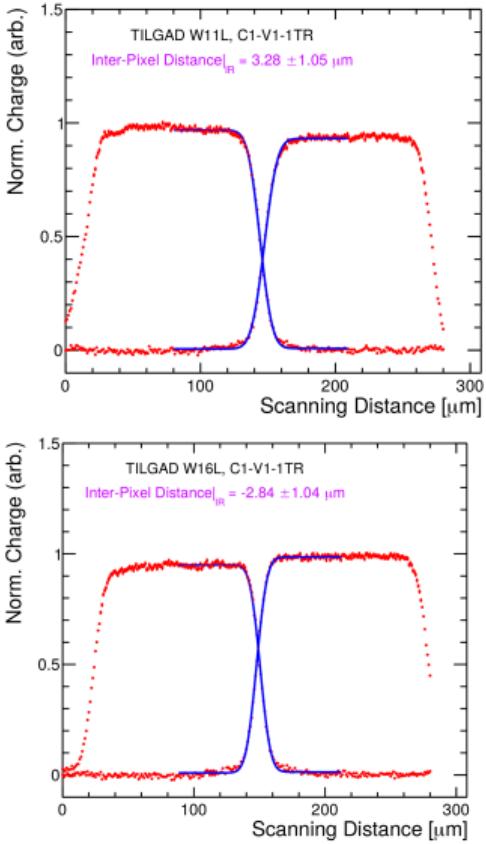
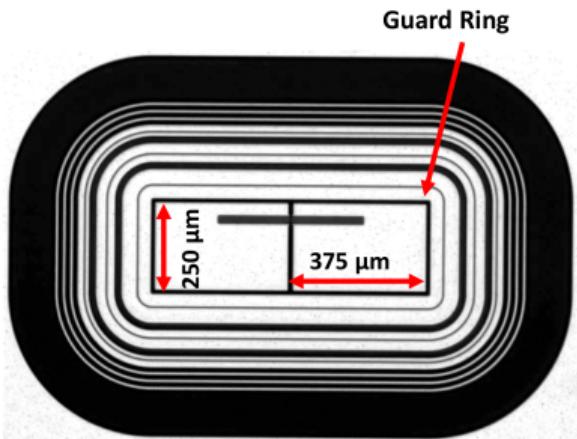
Nominal Gain region **Inter-strip border**
146 μm strips



Signal vs position for 3 strips

[M. Andrae, J. Zhang, et al. J. Synchrotron Rad. (2019)]

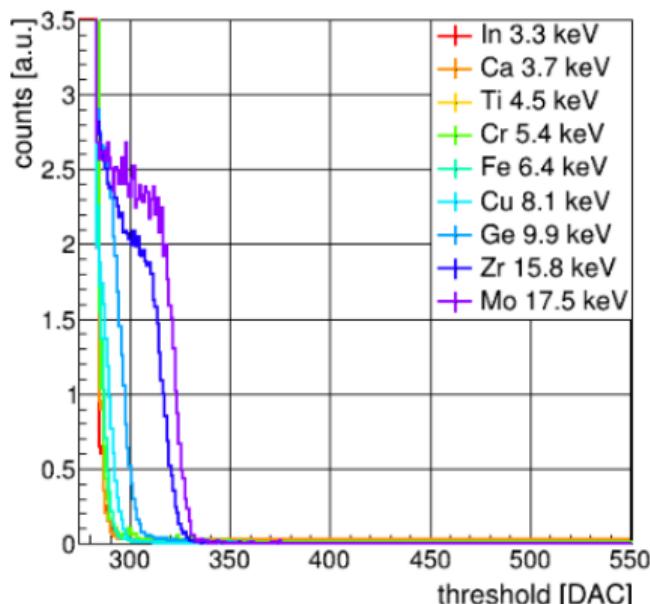
Interpad Distance TI-LGADs



Low Energy X-ray Detection

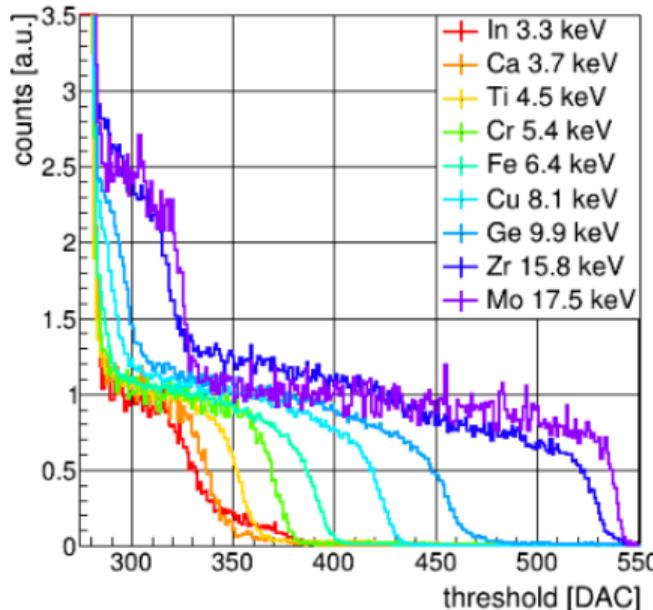
Photon counting strip detectors, fluorescence X-rays

PiN sensor



$E > 8 \text{ keV visible}$

LGAD sensor



$E < 3.3 \text{ keV visible}$

Improvement in detection threshold

[A. Bergamaschi TREDI2019]

[M. Andrae, J. Zhang, et al. J. Synchrotron Rad. (2019)]